



PATENT APPLICATION

April 15, 2005

JRW \$

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant : Hiroshi KAWAURA

Title : METHOD FOR FORMING CVD FILM

Serial No. : 10/692 655 Group: 1762

Confirmation No.: 9922

Filed : October 24, 2003 Examiner: Meeks

Atty. Docket No.: Ishii Case 20

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Herewith is an amendment in the above-identified application.

- [X] Applicant claims small entity status. See 37 CFR 1.27.  
[X] The additional filing fee has been calculated as shown below:

For	No. Filed	No. Extra	() RATE LG Entity	(X) RATE SM Entity	Fee
Total Claims	(7 - 20 = 0)		x \$ 50.00	x \$ 25.00	
Indep. Claims	(4 - 3 = 1)		x \$200.00	x \$100.00	100.00
[ ] Multiple Dep. Claim			+ \$360.00	+ \$180.00	
* * * TOTAL FILING FEE * * *					\$ 100.00

- [X] Pursuant to 37 CFR 1.136(a), please extend the shortened period for response by one month. The extension fee is: \$60.00.  
[X] A Check for \$160.00 is enclosed to cover fees.  
[X] Please credit any overpayment, or charge any additional filing fee required under 37 CFR 1.16 or 1.17 by this communication, to Deposit Account No. 06-1382. A duplicate copy of this sheet is enclosed.

IN DUPLICATE

TFC/smd

  
Terrance F. Chapman Reg. No. 32 549

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 15, 2005.

04/18/2005 AKELECH1 00000014 10692655

60.00 DP

02 FC:2251

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Terrance F. Chapman